



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto IIDA et al.

Group Art Unit: 1765

Application No.: 09/869,912

Examiner: R. Kunemund

Filed: July 9, 2001

Docket No.: 110051

For: SILICON SINGLE CRYSTAL WAFER AND PRODUCTION METHOD THEREOF  
AND SOI WAFER

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the April 2, 2004 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**